

<b>Notice of References Cited</b>	Application/Control No. 09/071,900		Applicant(s)/Patent Under Reexamination HUMMEL ET AL.	
	Examiner Qi Han		Art Unit 2654	Page 1 of 1

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*	C	US-5,224,040 A	06-1993	Tou, Julius T.	704/2
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**NON-PATENT DOCUMENTS**

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